

<b>Notice of References Cited</b>	Application/Control No. 09/866,665	Applicant(s)/Patent Under Reexamination KONDO ET AL.	
	Examiner Brian L. Mutschler	Art Unit 1753	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-6,706,335	03-2004	Kondo et al.	427/574
B	US-			
C	US-			
D	US-			
E	US-			
F	US-			
G	US-			
H	US-			
I	US-			
J	US-			
K	US-			
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**FOREIGN PATENT DOCUMENTS**

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N					
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**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
U	"Silicon Tetrafluoride" at <a href="http://www.scottsemicon.com/pures/sif4.html">http://www.scottsemicon.com/pures/sif4.html</a> (undated)
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